



**ELECTRONIC COPY**

LG670454067  
Report verification at igi.org



December 24, 2024

IGI Report Number **LG670454067**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **8.83 X 6.29 X 4.24 MM**

**GRADING RESULTS**

Carat Weight **2.08 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

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Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

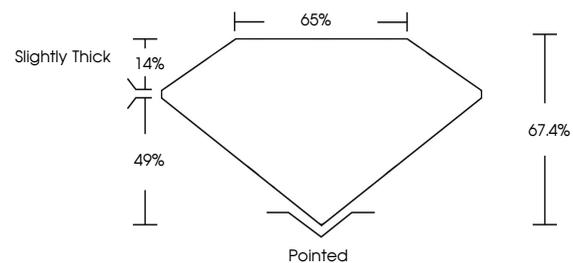
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG670454067**

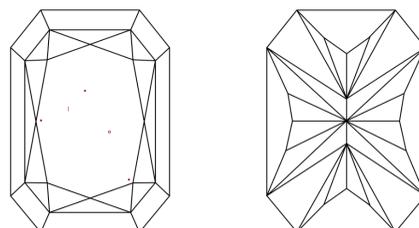
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

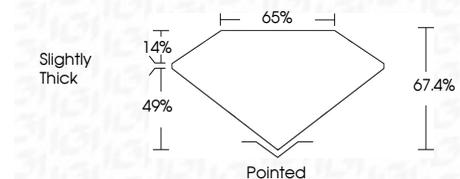
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
8.83 X 6.29 X 4.24 MM  
2.08 CARATS  
D  
Color Grade  
VS 1  
Depth 67.4%  
Table 65%  
Girdle Slightly Thick  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG670454067

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